

CONTENTS

I. DYNAMICAL INSTABILITIES AND PULSATIONS IN LASERS

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§ 1.	INTRODUCTION	3
§ 2.	EARLY DEVELOPMENTS: MASER STUDIES	5
§ 3.	RATE EQUATION DESCRIPTION OF LASER ACTION: RELAXATION OSCILLATIONS	11
§ 4.	SEMICLASSICAL LASER EQUATIONS	22
4.1	Early history	22
4.2	Semiclassical equations of motion of the laser	25
4.3	The simplest laser model – the homogeneously broadened laser	26
4.4	Steady-state behavior	31
4.5	Linear stability analysis of the laser equations	36
§ 5.	THE SINGLE-MODE LASER: STEADY STATES AND STABILITY ANALYSIS	55
§ 6.	NUMERICAL RESULTS FOR THE TIME-DEPENDENT BEHAVIOR OF THE LASER IN THE SINGLE-MODE MODEL	62
§ 7.	EXPERIMENTAL OBSERVATIONS OF INSTABILITIES IN SINGLE-MODE, HOMOGENEOUSLY BROADENED LASERS	69
§ 8.	EFFECTS OF INHOMOGENEOUS BROADENING	73
8.1	Single-mode laser	88
8.2	Multimode laser	100
§ 9.	THE LASER WITH A SATURABLE ABSORBER (LSA)	104
9.1	Background	104
9.2	Semiclassical uniform field equations	107
9.3	Steady-state solutions	109
9.3.1	Resonant solutions	111
9.3.2	Nonresonant solutions	112
9.3.3	Steady-state diagrams	114
9.4	Time-dependent solutions (symmetry properties)	116
9.5	Linear stability analysis (resonant solutions)	118
9.5.1	$I = I_0 = 0$ solution	118
9.5.2	$I = I_-$ solution	119
9.5.3	$I = I_+$ solution	119
9.6	Linear stability analysis (nonresonant modes) $I = \tilde{I}, \Delta \neq 0$	120
9.7	Periodic and quasiperiodic solutions	121
9.8	Rate equations (resonant solutions)	126
9.8.1	Finite pump parameter	126
9.8.2	Large pump parameter	128
9.9	Pulsed solutions	132
9.10	The case of detuning between the cavity and material resonances or between the absorber and amplifier resonances	134

§ 10. OTHER TOPICS ON LASER STABILITY AND PULSATIONS	136
10.1 Single-mode lasers	136
10.1.1 Fabry–Perot lasers	136
10.1.2 Classification of lasers by their parameter ranges and simplified models	136
10.1.3 Transverse effects	139
10.1.4 Lasers with modulated parameters (LMP)	140
10.1.5 Laser with swept parameters	142
10.1.6 Laser with injected signal (LIS)	143
10.1.7 Optically pumped lasers, the Raman laser	145
10.1.8 Radio-frequency “laser” (RASER)	146
10.1.9 Laser with phase conjugate mirrors	146
10.1.10 Laser with electro-optic feedback	146
10.1.11 Semiconductor lasers	147
10.1.12 Second-harmonic generation in lasers	148
10.1.13 Free-electron lasers	148
10.1.14 Two-photon laser	149
10.1.15 Systems with noise	149
10.2 Multimode lasers	150
10.2.1 Standing-wave lasers	151
10.2.2 Modelocking	152
10.2.3 Two-mode laser behavior	152
10.2.3.1 Bidirectional ring laser	153
10.2.3.2 Bichromatic operation of a dye laser	154
10.2.3.3 Polarization switching	154
10.2.3.4 Pairs of spatially different modes	155
10.2.4 Laser with external mirror, external resonators, and coupled cavities	155
10.2.5 Multitransverse modes	156
10.2.6 Intermode correlations	157
10.3 Chaos in lasers	157
ACKNOWLEDGEMENTS	159
APPENDIX A: THE SOLVABILITY CONDITION	160
NOTE ADDED IN PROOF	165
REFERENCES	167

II. COHERENCE IN SEMICONDUCTOR LASERS

by M. OHTSU and T. TAKO (TOKYO, JAPAN)

§ 1. INTRODUCTION	193
§ 2. STRUCTURES AND OSCILLATION MECHANISMS	194
2.1 Structures	194
2.2 Oscillation mechanisms and their formulation	198
§ 3. NOISE AND TEMPORAL COHERENCE	201
3.1 Intensity noise	201
3.2 Frequency noise	203
3.3 Spectral linewidth	205
§ 4. IMPROVEMENT OF TEMPORAL COHERENCE	208
4.1 Comparisons with microwave oscillators and other types of lasers	209
4.2 Theoretical background of negative feedback for improving temporal coherence	211

4.3	Experimental approach for frequency noise reduction	216
4.3.1	Linewidth reduction of the field spectrum	216
4.3.2	Stabilization of the center frequency of the field spectrum	220
4.3.3	Improvement of frequency reproducibility	222
4.3.4	Frequency tracking to another, highly coherent laser	223
4.3.5	Stable and wideband frequency sweep	228
4.4	Design of novel semiconductor lasers to improve coherence	233
§ 5.	DETERIORATION OF COHERENCE CAUSED BY SPECIFIC NOISE IN SEMICONDUCTOR LASERS	234
5.1	Oscillation instabilities induced by reflected lightwave and chaos	235
5.2	Mode-hopping noise	238
§ 6.	APPLICATIONS OF HIGHLY COHERENT SEMICONDUCTOR LASERS	247
6.1	Optical measurements and optical fiber sensors	248
6.2	Coherent optical communication	252
6.3	Atomic and molecular spectroscopy	258
6.4	Optical pumping in cesium and rubidium atomic clocks	261
6.4.1	Cesium atomic clocks	263
6.4.2	Rubidium atomic clocks	267
§ 7.	SUMMARY	273
	APPENDIX	273
	REFERENCES	274

III. PRINCIPLES AND DESIGN OF OPTICAL ARRAYS

by WANG SHAOMIN (HANGZHOU, CHINA) and L. RONCHI (FLORENCE, ITALY)

§ 1.	INTRODUCTION	281
§ 2.	THE 2×2 MATRIX TREATMENT OF AN ALIGNED OPTICAL ELEMENT	284
2.1	Sign conventions	284
2.2	Definition of the ray transfer matrix	286
2.3	Basic methods for deriving ray transfer matrices	287
2.4	Image forming matrix	297
2.5	Application of matrix methods to non-Gaussian imaging	301
2.6	The eikonal function and the Fresnel number of a centered system	303
§ 3.	MATRIX TREATMENT FOR MISALIGNED ELEMENTS	305
3.1	The 4×4 ray transfer matrix	305
3.2	Eikonal function for misaligned systems	309
§ 4.	MATRIX TREATMENT OF ARRAYS	311
4.1	General considerations	311
4.2	The ray transfer matrix for an array	311
4.3	Additional aberrations for arrays	317
4.4	Interference effects in the synthesized image	319
§ 5.	PSEUDO CONJUGATOR ARRAYS	323
5.1	Phase-conjugation mirrors	323
5.2	Phase-conjugator arrays	326
5.3	Corner-cube array	333
5.4	Cat's-eye array	334
5.5	Roof-mirror array	335
5.6	Grin rod arrays, thick-lens arrays and bead arrays	337

§ 6. ARRAYS WITH VANISHING DETERMINANT	341
6.1 Theoretical considerations	341
6.2 Experimental tests	345
§ 7. CONCLUSION	346
ACKNOWLEDGEMENTS	347
REFERENCES	347

IV. ASPHERIC SURFACES

by G. SCHULZ (BERLIN-ADLERSHOF, GDR)

§ 1. INTRODUCTION	351
§ 2. TYPES OF ASPHERICS AND THEIR MATHEMATICAL REPRESENTATION	352
2.1 Surfaces of revolution about the optical axis	352
2.2 Other types of aspherics	356
§ 3. DESIGN OF ASPHERICS	357
3.1 Design goals	358
3.2 Simple solutions using conic sections	360
3.3 Determinations in near-axis regions	362
3.4 Ray tracing through aspherics	367
3.5 System optimization using a merit function	371
3.6 Attainment of axial stigmatism and differential equations for various purposes	372
3.7 Point-by-point computation by ray constructions without differential equations	382
§ 4. FABRICATION AND TESTING METHODS	387
4.1 Fabrication methods	387
4.2 References to the literature for testing methods	390
§ 5. FIELDS OF APPLICATION	391
5.1 Mirror telescopes	392
5.2 Photolenses, wide-angle systems, and zoom lenses	394
5.3 Ophthalmic lenses	395
5.4 Systems for nonvisible spectral regions	397
5.5 Focusing of laser beams and irradiance redistribution	399
5.6 Illuminating systems and concentrators	400
5.7 Further applications	401
§ 6. LIMITS OF THE IMAGING PERFORMANCE OF ASPHERICS	403
6.1 Sharp and perfect imaging	403
6.2 Aberration-free imaging with small field angles or pencil diameters	404
6.3 Problems with the number of resolvable points	406
6.4 Imaging performance of aspherics compared with spherical surfaces	408
ACKNOWLEDGEMENTS	410
REFERENCES	410
AUTHOR INDEX	417
SUBJECT INDEX	435
CUMULATIVE INDEX, VOLUMES I-XXV	439